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# Requirements for Super-XAS beamline (X10DA) at SLS

Maarten Nachtegaal André M. Scheidegger Daniel Grolimund Rafael Abela

Paul Scherrer Institut CH-5232 Villigen PSI Switzerland

## Philosophy:

• The optical design of the beamline should be optimized towards maximizing the photon flux at the sample (3D-XAS, EXAFS of diluted samples) and towards a high energy resolution

## **Operation Modes:**

- A. Stable conventional bulk EXAFS from 4 ~50 keV,  $< \Delta E/E = 2.10^{-4}$ )
- B. Ouick-EXAFS for time-resolved studies  $(4 \sim 50 \text{ keV}, < \Delta E/E = 2.10^{-4})$
- C. 3D-XAS by means of a fast scanning monochromator and dynamic focusing
  - beam size to be achieved:  $\sim 5 \times 5 \mu m^2$

#### Schemes:

• Optics hutch vs 'front-end optics'

#### **Beam Characteristics**

- Spectral range: 4- ~50 keV
- Energy resolution:  $< \Delta E/E = 2.10^{-4}$  (high flux, high resolution mode)
- Higher harmonic rejection: < 10<sup>-3</sup>
- Horizontal divergence: < 7 mrad, tunable
- Beam size: 5 x 5 μm to a few mm<sup>2</sup>
- Allowed beam fluctuations during measurements (constant beam):
  - Beam position: < 10% of beam size
- Allowed beam fluctuations during measurements (with bigger energy changes in monochromatic mode):
  - Horizontal beam position: < 5 μm
  - Vertical beam position: < 5 μm

## (Potential) important beamline components (to be evaluated by design study)

- Frontend (diaphragm, absorber, fast valves, shutter, stopper)
- Be window (diamond window developed by PSI)
- Conventional DCM with two or three pairs of crystals
- Piezo-EXAFS monochromator (for quick scanning EXAFS)
- Optics: pre-focusing?
- Focusing devices:
  - Focusing up to 50 keV
- Pb-shielded hutches (layout + thickness of wall will be given)
  - Optics hutch
  - Experimental hutch providing space for two optical tables

# Beamline components provided by SLS

- Superbend
- Experimental set-up in experimental hutch

# **Superbend characteristics:**

Location: X10DA (circumference of beamline on SLS floor-plan included)

Machine Parameters:

Ring energy: 2.4 GeV Ring current: 400 mA Gamma value: 4697

Source Parameters:

Magnetic field: 3.1 Tesla

Critical energy: 11.9 keV (1.04 Å)

Emittance  $(\varepsilon_x, \varepsilon_y)$ : 5 nm, 5 pm Beta functions  $(\beta_x, \beta_y)$ : 0.43 m, 10 m Photon source size  $(\Sigma_x, \Sigma_y)$ : 53  $\mu$ m, 16  $\mu$ m

Photon source divergence vertical: 0.6 mrad (Calculated with FWHM (=2.35\*sigma))

Photon source acceptance horizontal: < 7 mrad

Total integrated power: 143.682 Watt (for an emission angle of 2mrad H)